

| Ref # | Hits | Search Query                                                                                                                                                       | DBs                                                     | Default Operator | Plurals | Time Stamp       |
|-------|------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|------------------|---------|------------------|
| L1    | 1    | ("20020061658").PN.                                                                                                                                                | US-PGPUB;<br>USOCR                                      | OR               | OFF     | 2005/01/29 07:33 |
| L2    | 10   | ((("20030203622") or ("20020061658") or ("5310700") or ("5447887") or ("6413805") or ("6489230") or ("6004847") or ("5665620") or ("4376672") or ("6180457"))).PN. | US-PGPUB;<br>USPAT                                      | OR               | OFF     | 2005/01/29 07:42 |
| S1    | 1    | 438/255,258,201,261,257,756,757,724.ccls. and (((oxide adj nitride adj silicon) or ("ONS"))) same ((oxide adj nitride adj oxide) or ("ONO"))                       | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:10 |
| S2    | 4    | 438/255,258,201,261,257,756,757,724.ccls. and ((oxide adj nitride adj silicon) or ("ONS")) and ((oxide adj nitride adj oxide) or ("ONO"))                          | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:11 |
| S3    | 0    | 438/255,258,201,261,257,756,757,724.ccls. and (((oxide adj nitride adj silicon) or ("ONS"))) with ((oxide adj nitride adj oxide) or ("ONO"))                       | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:10 |
| S4    | 9    | "438"/\$.ccls. and (((oxide adj nitride adj silicon) or ("ONS"))) with ((oxide adj nitride adj oxide) or ("ONO"))                                                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:13 |
| S5    | 10   | "438"/\$.ccls. and (((oxide adj nitride adj silicon) or ("ONS"))) same ((oxide adj nitride adj oxide) or ("ONO"))                                                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:15 |
| S6    | 32   | "438"/\$.ccls. and ((oxide adj nitride adj silicon) or ("ONS")) and ((oxide adj nitride adj oxide) or ("ONO"))                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:16 |
| S7    | 36   | "257"/\$.ccls. and ((oxide adj nitride adj silicon) or ("ONS")) and ((oxide adj nitride adj oxide) or ("ONO"))                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 09:10 |
| S8    | 182  | semiconductor and ((oxide adj nitride adj silicon) or ("ONS")) and ((oxide adj nitride adj oxide) or ("ONO"))                                                      | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/09/10 11:09 |

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| S9  | 20   | semiconductor and (((oxide adj nitride adj silicon) or ("ONS"))) with ((oxide adj nitride adj oxide) or ("ONO"))) | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2004/09/10 09:10 |
| S10 | 22   | semiconductor and (((oxide adj nitride adj silicon) or ("ONS"))) same ((oxide adj nitride adj oxide) or ("ONO"))) | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2004/09/10 09:10 |
| S17 | 3    | ((("6004847") or ("5104819") or ("6274428"))).PN.                                                                 | USPAT;<br>USOCR                                                   | OR | OFF | 2004/09/10 13:11 |
| S18 | 524  | (438/255).CCLS.                                                                                                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:08 |
| S19 | 479  | (438/258).CCLS.                                                                                                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:10 |
| S20 | 271  | (438/261).CCLS.                                                                                                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:10 |
| S21 | 1104 | (438/257).CCLS.                                                                                                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:10 |
| S22 | 450  | (438/756).CCLS.                                                                                                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:11 |
| S23 | 116  | (438/757).CCLS.                                                                                                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:11 |

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| S24 | 308  | (438/724).CCLS.                                                                                                                                | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/01 10:11 |
| S25 | 3039 | 438/255,258,201,261,257,756,757,<br>724.ccls.                                                                                                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2002/11/01 10:15 |
| S26 | 14   | 438/255,258,201,261,257,756,757,<br>724.ccls. and (ONS or (oxide adj<br>nitride adj silicon))                                                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2004/09/10 09:06 |
| S27 | 1    | 438/255,258,201,261,257,756,757,<br>724.ccls. and ((ONS or (oxide adj<br>nitride adj silicon)) same (ONO or<br>(oxide adj nitride adj oxide))) | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2002/11/01 10:18 |
| S28 | 24   | (ONS or (oxide adj nitride adj<br>silicon)) same (ONO or (oxide adj<br>nitride adj oxide))                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2004/07/26 14:00 |
| S29 | 13   | ((ONS or (oxide adj nitride adj<br>silicon)) same (ONO or (oxide adj<br>nitride adj oxide))) and<br>semiconductor                              | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2002/11/04 10:07 |
| S30 | 8    | ((("6004847") or ("5104819") or<br>("6274428") or ("6180457") or<br>("6429470") or ("6318267") or<br>("5572050") or ("4775549")).PN.           | USPAT;<br>USOCR                                                   | OR | OFF | 2003/04/07 12:58 |
| S31 | 20   | ((ONS or (oxide adj nitride adj<br>silicon)) same (ONO or (oxide adj<br>nitride adj oxide))) and (photoresist<br>or mask)                      | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2003/10/01 08:00 |
| S32 | 10   | ((((ONS or (oxide adj nitride adj<br>silicon)) same (ONO or (oxide adj<br>nitride adj oxide))) and (photoresist<br>or mask)) and semiconductor | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR | ON  | 2002/11/04 10:10 |
| S33 | 191  | (438/201).CCLS.                                                                                                                                | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2002/11/04 11:17 |

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| S34 | 0     | ((ONO or (oxide adj nitride adj oxide)) same (ONS or (oxide adj nitride adj silicon)) same (photoresist or mask)) and (re-oxidiz\$6 or (second adj oxidiz\$6))               | USPAT;<br>JPO | OR | ON | 2003/04/07 12:34 |
| S35 | 0     | ((ONO or (oxide adj nitride adj oxide)) same (ONS or (oxide adj nitride adj silicon))) and (photoresist or mask) and (re-oxidiz\$6 or (second adj oxidiz\$6))                | USPAT;<br>JPO | OR | ON | 2003/04/07 12:38 |
| S36 | 0     | (ONO or (oxide adj nitride adj oxide)) and (ONS or (oxide adj nitride adj silicon)) and (photoresist or mask) and (re-oxidiz\$6 or (second adj oxidiz\$6)) and semiconductor | USPAT;<br>JPO | OR | ON | 2003/04/07 12:38 |
| S37 | 66    | (ONO or (oxide adj nitride adj oxide)) and (ONS or (oxide adj nitride adj silicon))                                                                                          | USPAT;<br>JPO | OR | ON | 2003/04/07 12:38 |
| S38 | 80283 | (ONO or (oxide adj nitride adj oxide)) or (ONS or (oxide adj nitride adj silicon))                                                                                           | USPAT;<br>JPO | OR | ON | 2003/04/07 12:38 |
| S39 | 23    | (ONO or (oxide adj nitride adj oxide)) same (ONS or (oxide adj nitride adj silicon))                                                                                         | USPAT;<br>JPO | OR | ON | 2003/04/07 12:38 |
| S40 | 0     | ((ONO or (oxide adj nitride adj oxide)) and (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and (re-oxidiz\$6 or (second adj oxidiz\$6))                | USPAT;<br>JPO | OR | ON | 2003/04/07 12:39 |
| S41 | 0     | ((ONO or (oxide adj nitride adj oxide)) same (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and (re-oxidiz\$6 or (second adj oxidiz\$6))               | USPAT;<br>JPO | OR | ON | 2003/04/07 12:41 |
| S42 | 11    | ((ONO or (oxide adj nitride adj oxide)) same (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and semiconductor                                          | USPAT;<br>JPO | OR | ON | 2003/04/07 12:40 |
| S43 | 22    | ((ONO or (oxide adj nitride adj oxide)) and (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and semiconductor                                           | USPAT;<br>JPO | OR | ON | 2003/04/07 12:40 |

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| S44 | 36  | ((ONO or (oxide adj nitride adj oxide)) or (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and (re-oxidiz\$6 or (second adj oxidiz\$6)) | USPAT;<br>JPO                                           | OR | ON  | 2003/04/07 12:40 |
| S45 | 0   | ((ONO or (oxide adj nitride adj oxide)) same (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and (second adj oxidiz\$6)                 | USPAT;<br>JPO                                           | OR | ON  | 2003/04/07 12:41 |
| S46 | 0   | ((ONO or (oxide adj nitride adj oxide)) and (ONS or (oxide adj nitride adj silicon)) ) and (photoresist or mask) and (second adj oxidiz\$6)                  | USPAT;<br>JPO                                           | OR | ON  | 2003/04/07 12:41 |
| S47 | 10  | ((("5756376") or ("5770467") or ("6318267") or ("6004847") or ("6429470") or ("6180457") or ("5104819") or ("5572050") or ("6472259") or ("4775549")).PN.    | USPAT;<br>USOCR                                         | OR | OFF | 2003/04/08 09:24 |
| S48 | 1   | ("5650344").PN.                                                                                                                                              | USPAT;<br>USOCR                                         | OR | OFF | 2003/04/08 09:37 |
| S49 | 5   | ((("5650344") or ("4698787") or ("4543597") or ("5049514") or ("5083172")).PN.                                                                               | USPAT;<br>USOCR                                         | OR | OFF | 2003/04/08 09:38 |
| S50 | 8   | ((("6225162") or ("6388305") or ("6168987") or ("6133602") or ("5591681") or ("5436481") or ("6133093") or ("6096604")).PN.                                  | USPAT;<br>USOCR                                         | OR | OFF | 2003/04/18 13:51 |
| S51 | 9   | ((("6225162") or ("6388305") or ("6168987") or ("6133602") or ("5591681") or ("5436481") or ("6133093") or ("6096604") or ("5572050")).PN.                   | USPAT;<br>USOCR                                         | OR | OFF | 2003/04/18 15:09 |
| S52 | 1   | ("6004847").PN.                                                                                                                                              | USPAT;<br>USOCR                                         | OR | OFF | 2003/09/30 13:31 |
| S53 | 150 | "438"/\$.ccls. and (oxide adj nitride adj silicon) and (photoresist or resist or mask) and @ad<="20011130"                                                   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 13:38 |
| S54 | 100 | "438"/\$.ccls. and (oxide adj nitride adj silicon) and (photoresist) and @ad<="20011130"                                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 10:58 |
| S55 | 21  | "438"/\$.ccls. and ((oxide adj nitride adj silicon) same (photoresist)) and @ad<="20011130"                                                                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 11:08 |

|     |       |                                                                                                                                                 |                                                         |    |     |                  |
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| S56 | 13829 | "438"/\$.ccls. and ((silicon) same (photoresist)) and @ad<="20011130"                                                                           | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 13:35 |
| S57 | 13    | 438/255,258,201,261,257,756,757, 724.ccls. and (ONS or (oxide adj nitride adj silicon)) and (photoresist or resist or mask) and @ad<="20011130" | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 11:11 |
| S58 | 3     | 438/255,258,201,261,257,756,757, 724.ccls. and ((oxide adj nitride adj silicon) same (photoresist or resist or mask)) and @ad<="20011130"       | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 11:20 |
| S59 | 1     | ("4376672").PN.                                                                                                                                 | USPAT;<br>USOCR                                         | OR | OFF | 2003/09/30 13:43 |
| S60 | 982   | 438/255,258,201,261,257,756,757, 724.ccls. and ((silicon) same (photoresist)) and @ad<="20011130"                                               | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 13:35 |
| S61 | 265   | "438"/\$.ccls. and (ONS or (oxide adj nitride adj silicon)) and (photoresist or resist or mask) and @ad<="20011130"                             | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/10/01 07:57 |
| S62 | 10826 | nguyen.inv.                                                                                                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 13:38 |
| S63 | 51    | nguyen.inv. and (bich-yen)                                                                                                                      | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 13:38 |
| S64 | 51    | (nguyen.inv. and (bich-yen)) and motorola                                                                                                       | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON  | 2003/09/30 13:38 |
| S65 | 2     | ((("4376672") or ("5665620"))).PN.                                                                                                              | USPAT;<br>USOCR                                         | OR | OFF | 2003/09/30 13:49 |
| S66 | 9     | ((("4376672") or ("5665620") or ("6472259") or ("5104819") or ("6180457") or ("6168987") or ("5591681") or ("6096604") or ("5358892"))).PN.     | USPAT;<br>USOCR                                         | OR | OFF | 2003/09/30 14:02 |
| S67 | 1     | ("20020117736").PN.                                                                                                                             | US-PGPUB;<br>USOCR                                      | OR | OFF | 2003/09/30 14:07 |

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| S68 | 18265 | "438"/\$.ccls. and (ONS or (oxide same nitride same silicon)) and (photoresist or resist or mask) and @ad<="20011130"            | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 07:58 |
| S69 | 2092  | 438/255,258,201,261,257,756,757, 724.ccls. and (ONS or (oxide same nitride same silicon))                                        | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 07:59 |
| S70 | 2090  | 438/255,258,201,261,257,756,757, 724.ccls. and (oxide same nitride same silicon)                                                 | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 07:59 |
| S71 | 585   | 438/255,258,201,261,257,756,757, 724.ccls. and ((oxide same nitride same silicon) same photoresist)                              | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 08:01 |
| S72 | 537   | 438/255,258,201,261,257,756,757, 724.ccls. and ((oxide same nitride same silicon) same photoresist) and @ad<="20011130"          | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 08:09 |
| S73 | 537   | 438/255,258,201,261,257,756,757, 724.ccls. and ((ONS or (oxide same nitride same silicon)) same photoresist) and @ad<="20011130" | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 08:25 |
| S74 | 0     | 438/255,258,201,261,257,756,757, 724.ccls. same (high adj voltage adj oxide)                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 14:26 |
| S75 | 11    | 438/255,258,201,261,257,756,757, 724.ccls. and (high adj voltage adj oxide)                                                      | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 14:27 |
| S76 | 11    | 438/255,258,201,261,257,756,757, 724.ccls. and (high adj voltage adj oxide) and @ad<="20011120"                                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2003/10/01 14:27 |
| S77 | 36    | ((("ONS") or (oxide adj nitride adj silicon)) same ((("ONO") or (oxide adj nitride adj oxide)) and @ad<="20011120"               | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2004/07/26 14:01 |

|     |      |                                                                                                                                   |                                                         |    |    |                  |
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| S78 | 19   | ((oxide adj nitride adj silicon) or ("ONS")) with ((oxide adj nitride adj oxide) or ("ONO")) and @ad<="20011120"                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2004/07/26 14:03 |
| S79 | 36   | ((oxide adj nitride adj silicon) or ("ONS")) same ((oxide adj nitride adj oxide) or ("ONO")) and @ad<="20011120"                  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2004/07/27 07:07 |
| S80 | 0    | "20020061658".URPN.                                                                                                               | USPAT                                                   | OR | ON | 2004/07/27 07:02 |
| S81 | 1689 | ((oxide adj nitride adj silicon) or ("ONS")) and ((oxide adj nitride adj oxide) or ("ONO")) and @ad<="20011120"                   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2004/07/27 07:09 |
| S82 | 159  | ((oxide adj nitride adj silicon) or ("ONS")) and ((oxide adj nitride adj oxide) or ("ONO")) and @ad<="20011120" and semiconductor | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | ON | 2004/07/27 07:10 |